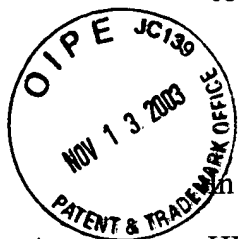


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1763  
PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIDEO KITAGAWA ET AL.

Application No.: 09/832,978

Filed: April 12, 2001

For: METHOD OF ETCHING  
ORGANIC FILM AND METHOD  
OF PRODUCING ELEMENT

)  
:  
Examiner: A. Olsen

)  
:  
Group Art Unit: 1763

)  
:  
November 12, 2003

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TC 1700

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 022313-1450

AMENDMENT

Sir:

A. Introductory Comments

In response to the Office Action dated August 13, 2003, kindly amend the  
above-captioned application as follows and consider the following remarks.